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10/748,828

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**Application Number** 

I TRANSMITTAL				Filing Date	December 29, 2003		
P` S FORM			First Inventor	Han-Hsing Liu			
THE 1 6 SURV. TO			Confirmation No.	:7167			
2/			Group Art Unit	2818			
(to be used all correspondence after initial filing)			Examiner Name	Renee R. Berry			
Total	Number Of Pages In Th	nis Submission 2		Attorney Docket No.	DAF00	9 US	
ENCLOSURES (check all that apply)							
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	Response to Missing Parts under 37 CFR 1.52 or 1.53						
CICNATURE OF ARRUSOMET ATTORNEY OR ACCUT							
SIGNATURE OF APPLICANT, ATTORNEY OR AGENT  Firm Michael J. Halbert (Reg. No. 40,633)							
I .			Silicon Valley Patent Group LLP				
Individual Name		2350 Mission College Boulevard, Suite 360					
		Santa Clara, California 95054					
Signature		Wirles 9 Halle					
July 16, 2004 Date							
EXPRESS MAIL LABEL NO: EV 450 194 628 US							



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors:

Han-Hsing Liu

Assignee:

Winbond Electronics Corporation

Title:

Polycide Gate Stucture and Manufacturing Method Thereof

Serial No.:

10/748,828

Filing Date:

December 29, 2003

Examiner:

Renee R. Berry

Group Art Unit:

2818

7167

Docket No.:

DAF009 US

Confirmation No.:

Santa Clara, California July 16, 2004

MAIL STOP AMENDMENT COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

## RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

In Response to the Restriction Requirement dated June 30, 2004, Applicants elect without traverse to have the invention of Group II, Claims 22-32, examined. Please withdraw from consideration Claims 1-21, which are drawn to the invention of Group I. Applicants reserve the right to seek examination of the invention of Group I in a divisional application.

It is believed that no fees are due. Nevertheless, if the Patent Office determines that an extension and/or other relief is required, Patent Owner petitions for any required relief including extensions of time and authorizes the Commissioner to charge the cost of such petitions and/or other fees due in connection with this filing of this document to **Deposit**Account No. 50-2263 referencing DAF009 US.

Should the Examiner have any questions concerning this response, the Examiner is invited to call the undersigned at (408) 982-8200, ext. 2.

Via Express Mail Label No. EV 450 194 628 US Respectfully submitted,

Michael J. Halbert Attorney for Applicants

Reg. No. 40,633

Serial No. 10/748,828

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